

<b>Notice of References Cited</b>	Application/Control No. 09/981,794	Applicant(s)/Patent Under Reexamination KONDO ET AL.	
	Examiner Paulos M. Natnael	Art Unit 2614	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,630,961 B1	10-2003	Shin et al.	348/448
	B	US-5,519,451 A	05-1996	Clatanoff et al.	348/606
	C	US-6,459,455 B1	10-2002	Jiang et al.	348/452
	D	US-6,348,949 B1	02-2002	McVeigh, Jeffrey S.	348/452
	E	US-6,259,480 B1	07-2001	Yamauchi et al.	348/452
	F	US-5,410,356 A	04-1995	Kikuchi et al.	348/452
	G	US-5,917,554 A	06-1999	Ohta, Masashi	348/581
	H	US-6,034,734 A	03-2000	De Haan et al.	348/458
	I	US-6,757,022 B2	06-2004	Wredenhagen et al.	348/452
	J	US-6,331,874 B1	12-2001	de Garrido et al.	348/452
	K	US-5,532,750 A	07-1996	De Haan et al.	348/452
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.